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In re the Application of: **Yoshihiro SUGITA et al.**

Group Art Unit: **2823**

Application Number: **10/633,534**

Examiner: **Brook Kebede**

Filed: **August 5, 2003**

Confirmation Number: **6460**

For: **MANUFACTURE METHOD FOR SEMICONDUCTOR DEVICE
WITH PATTERNED FILM OF ZrO₂ OR THE LIKE**

Attorney Docket Number: **030862**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

August 15, 2005

Sir:

In response to the Office Action dated May 17, 2005, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.